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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Noriyasu Sakai et al.

Art Unit : 2812

Serial No. : 10/667,681

Examiner : Scott B Geyer

Filed : September 22, 2003

Title : METHOD FOR MANUFACTURING CIRCUIT DEVICES

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF JULY 27, 2005

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

January 20, 2006

Date of Deposit

Rose Syracuse

Signature

Rose Syracuse

Typed or Printed Name of Person Signing Certificate